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FAV 2813
PATENT

Case Docket No. ASMMC.036AUS

Date: August 20, 2002

Page 1

In re application of : SOPHIE et al.
App. No. : 09/975,466
Filed : October 9, 2001
For : IN SITU REDUCTION OF
COPPER OXIDE PRIOR TO
SILICON CARBIDE
DEPOSITION
Examiner : Kielin, E.
Art Unit : 2813

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